

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In Application of:

Iwen Chao

Application No.: 10/779,379

Filed: February 12, 2004

For: SEMICONDUCTOR DEVICE WITH  
LOW RESISTIVE PATH BARRIER

Examiner: Mai, Anh D.

Art Unit: 2814

Confirmation No.: 8999

**CERTIFICATE OF TRANSMISSION/MAILING**

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450 on the date shown below:

Typed or Printed: Heather L. Adamson

Signature:  Date: 02/13/2006

Mail Stop RCE  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE ACCOMPANYING RCE**  
**INTRODUCTORY COMMENTS**

Dear Sir:

This communication is submitted in response to the Final Office Action mailed December 21, 2005 (hereinafter "Office Action"). Applicant respectfully requests reconsideration of the above-identified application in view of the amendments and remarks to follow.

**Amendments to the Specification** begin on page **2** of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begin on page **3** of this paper.

**Amendments to the Drawings** begin on page **8** of this paper and includes an attached new drawing sheet.

**Arguments/Remarks** begin on page **9** of this paper.

An **Appendix** including a new drawing sheet is attached following page **12** of this paper.